IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of: |) | |
|-------------------------------|---|------------------------|
| | : | Examiner: K. Fernandez |
| Masato MURAKI et al. |) | |
| | : | Group Art Unit: 2881 |
| Application No.: 09/708,590 |) | |
| | : | Allowed: June 4, 2003 |
| Filed: November 9, 2000 |) | |
| | : | Confirmation No.: 2106 |
| For: CORRECTING METHOD FOR |) | |
| CORRECTING EXPOSURE DATA USED | : | September 3, 2003 |
| FOR A CHARGED PARTICLE BEAM |) | |
| EXPOSURE SYSTEM | : | |

Mail Stop RCE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED FORMAL DRAWING

Sir:

Transmitted herewith is one (1) sheet of a formal drawing, Figure 5, to be substituted for the corresponding drawing sheet currently on file in the above-identified application.

This formal drawing incorporates the changes requested by Applicants in a Request for Approval of Drawing Changes filed on January 28, 2003, which were subsequently approved by the Examiner in the Notice of Allowability dated June 4, 2003.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

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